DOCKET NO: 246683US90CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TAKAHISA KIKUCHI : ATTN: APPLICATION DIVISION

SERIAL NO: NEW APPLN.

FILED: HEREWITH

FOR: EVALUATION METHOD,

POSITION DETECTION METHOD,

EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, AND EXPOSURE

APPARATUS

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 20 of this paper.